

FORM 1449*	Docket Number: 1001.1505101	Application Number: 10/001,396	
INFORMATION DISCLOSURE STATEMENT IN AN APPLICATION		Applicant: Salahieh et al.	
(Use several sheets if necessary)		Filing Date: October 18, 2001	Group Art Unit: 3763

EXAMINER: <u>Jae E. Lee</u>	DATE CONSIDERED: <u>5/24/04</u>
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EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form for next communication to the Applicant.

<p>FORM 1449*</p> <p>U.S. PATENT & TRADEMARK OFFICE</p> <p>INFORMATION DISCLOSURE STATEMENT IN AN APPLICATION</p> <p>(Use several sheets if necessary)</p> <p>JUL 22 2002</p>	Docket Number:	Application Number:
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U.S. Patent Documents					
Examiner Initial	DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS
DP	6,344,049	02/05/02	Levinson et al.		
	6,319,268	11/20/01	Ambrisco et al.	RECEIVED	
	6,309,399	10/30/01	Barbut et al.	JUL 25 2002	
	6,290,710	09/18/01	Cryer et al.	TECHNOLOGY CENTER R3700	
	6,287,321	09/11/01	Jang		
	6,280,413	08/28/01	Clark et al.		
	6,277,139	08/21/01	Levinson et al.		
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	6,270,513	08/07/00	Tsugita et al.		
	6,264,672	07/24/01	Fisher		
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	6,258,115	07/10/01	Dubrul		
	6,245,089	06/12/01	Daniel et al.		
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MM	6,051,015	04/18/00	Maahs		

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JUL 22 2002
PATENT & TRADEMARK OFFICE
U.S. DEPARTMENT OF COMMERCE*

U.S. Patent Documents					
Examiner Initial	DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS
70	6,042,598	03/28/00	Tsugita et al.	<i>JUL 25 2002</i>	<i>IVED</i>
70	5,980,555	11/09/99	Barbut et al.		<i>TECHNOLOGY CENTER R3700</i>
70	5,792,157	08/11/98	Mische et al.		

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	WO 01/89413	11/29/01	WIPO	
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	WO 01/72205	10/04/01	WIPO	
	WO 01/70326	09/27/01	WIPO	
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	EP 1 127 556 A2	08/29/01	EPO	
	WO 01/60442	08/23/01	WIPO	
	WO 01/58382	08/16/01	WIPO	
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	WO 01/21077	03/29/01	WIPO	
	WO 01/15629	03/08/01	WIPO	
	WO 01/10320	02/15/01	WIPO	

EXAMINER: <i>DeeDee Hall</i>	DATE CONSIDERED: <i>5/24/04</i>
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WO 01/08743	02/08/01	WIPO		
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WO 00/07521	02/17/00	WIPO		
FR 2 694 687	08/12/92	FR		English Abstract

OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

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